



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

May 30, 2026

IGI Report Number

LG804647591

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

7.11 X 5.00 X 3.29 MM

GRADING RESULTS

Carat Weight

1.02 CARAT

Color Grade

D

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

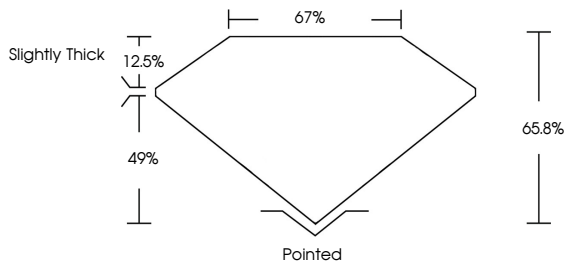
Inscription(s)

 LG804647591

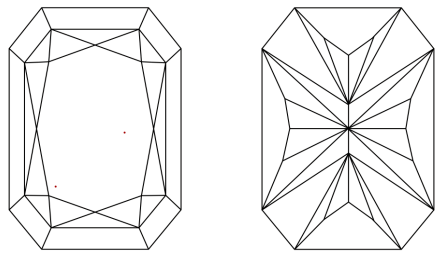
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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7.11 X 5.00 X 3.29 MM

Carat Weight

1.02 CARAT

D

Color Grade

D

VVS 2

Clarity Grade

VVS 2

65.8%

Depth

67%

Slightly Thick

Girdle

Slightly Thick

Pointed

Culet

Pointed

EXCELLENT

Polish

EXCELLENT

EXCELLENT

Symmetry

EXCELLENT

NONE

Fluorescence

NONE

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